

THE 5TH ISNM SYMPOSIUM ON ADVANCED MANUFACTURING AND MEASUREMENT: MICRO, NANO, ATOMIC AND CLOSE-TO- ATOMIC SCALE

The 5th ISNM Symposium on Advanced Manufacturing and Measurement: Micro, Nano, Atomic and Close-to-Atomic Scale will be held at Jilin University from June 14 to June 15, 2024 in Changchun, China. The event is jointly hosted by Jilin University and Tsinghua University, sponsored by the ISNM. This symposium will focus on the latest developments in advanced non-conventional manufacturing technologies with fabrication capabilities from atomic to micro scales, including but not limited laser fabrication, plasma technologies, nanoimprinting. The symposium will provide a communication and networking platform for young scientists in both fundamental and applied research areas and promote the development of new high-precision manufacturing technologies.